



IPW

Docket No.: 050432-0395

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor Application of	:	Customer Number: 20277
Akif SULTAN, et al.	:	Confirmation Number: 6644
Application No.: 10/759,171	:	Group Art Unit: 2812
Filed: January 20, 2004	:	Examiner: Isaac, Stanetta D.

For: METHOD OF FORMING MINIATURIZED POLYCRYSTALLINE SILICON GATE
ELECTRODES USING SELECTIVE OXIDATION

REQUEST FOR RECONSIDERATION

Mail Stop Request for Reconsideration
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Please
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SDE 8/18/05

Sir:

Reconsideration of the rejection under 35 U.S.C. § 103 imposed in the Office Action
dated June 27, 2005 is solicited in light of the following Remarks.